

Lecture 30 - The "Short" Metal-Oxide-Semiconductor Field-Effect Transistor

April 23, 2007

Contents:

1. Short-channel effects

Reading assignment:

P. K. Ko, "*Approaches to Scaling.*"

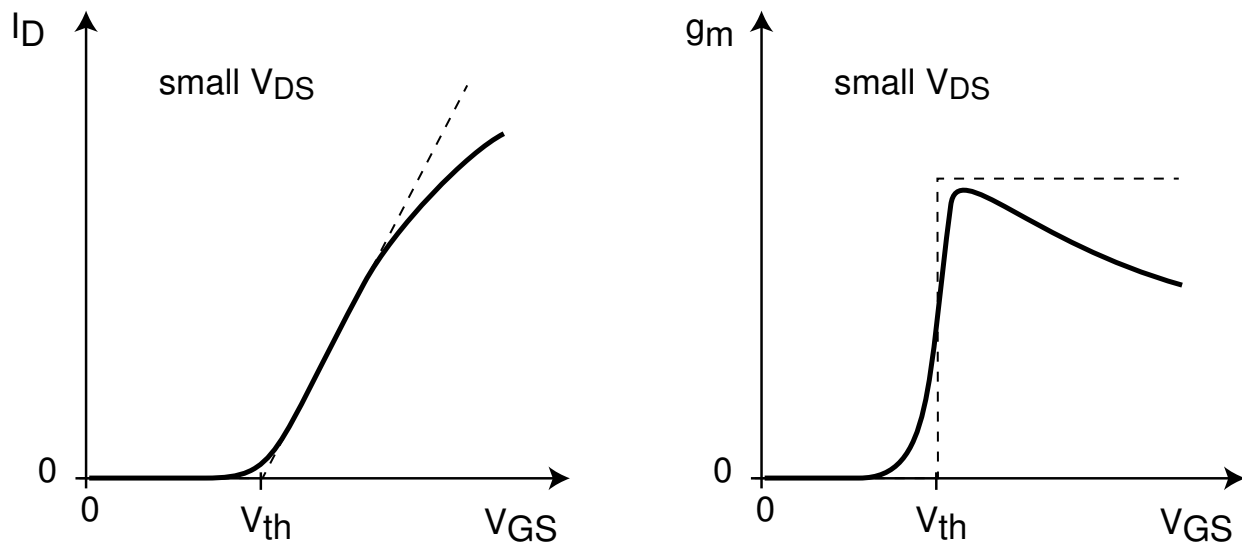
Key questions

- Why does it seem that in practice the drain current is significantly smaller than predicted by simple long MOSFET models?
- What is the impact of velocity saturation in the device characteristics?

1. Short-channel effects

□ **Mobility degradation:** mobility dependence on \mathcal{E}_x (vertical field).

Experimental observation in linear regime:



Experimental observation:

$$\mu_{eff} = \frac{\mu_o}{1 + \left| \frac{\mathcal{E}_{av}}{\mathcal{E}_o} \right|^\nu}$$

where \mathcal{E}_{av} is *average normal field in inversion layer*:

$$\mathcal{E}_{av} = \frac{Q_{dmax} + \frac{1}{2}Q_i}{\epsilon_s}$$

Due to *semiconductor-oxide interface roughness*.

μ_{eff} vs. \mathcal{E}_{av} : universal relationship for many MOSFET designs:

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Figure 4 in Ko, P. "Approaches to Scaling." *VLSI Electronics: Microstructure Science*. Edited by Norman G. Einspruch and Gennady Gildenblat. Vol. 18. Burlington, MA: Academic Press, 1989, chapter 1, pp. 1-37. ISBN: 9780122341182.

Parameters for the effective mobility models for electrons and holes:

	electrons	holes
μ_o ($cm^2/V \cdot s$)	670	160
\mathcal{E}_o (MV/cm)	0.67	0.7
ν	1.6	1

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Figure 6 in Ko, P. "Approaches to Scaling." *VLSI Electronics: Microstructure Science*. Edited by Norman G. Einspruch and Gennady Gildenblat. Vol. 18. Burlington, MA: Academic Press, 1989, chapter 1, pp. 1-37. ISBN: 9780122341182.

[from Arora and Richardson, *VLSI Electronics: Microstructure Science*, vol. 18, 1989.]

Simplified expression of \mathcal{E}_{av} for n^+ -polySi gate:

1) Relationship between Q_{dmax} and V_T :

$$V_T = V_{FB} + \phi_{sth} - \frac{Q_{dmax}}{C_{ox}}$$

with:

$$V_{FB} = -\phi_{bi} = \frac{1}{q}(W_M - W_S) = \frac{1}{q}(W_M - \chi_s - \frac{E_g}{2} - q\phi_f) = -\frac{1}{q} \frac{E_g}{2} - \phi_f$$

Plug into V_T and solve for Q_{dmax} :

$$Q_{dmax} = -C_{ox}(V_T + \frac{E_g}{2q} + \phi_f - 2\phi_f) = -C_{ox}(V_T + \frac{E_g}{2q} - \phi_f) \simeq -C_{ox}V_T$$

2) Relationship between Q_i and $V_{GS} - V_T$:

$$Q_i = -C_{ox}(V_{GS} - V_T)$$

3) Plug Q_{dmax} and Q_i into \mathcal{E}_{av} :

$$|\mathcal{E}_{av}| \simeq \left| \frac{Q_{dmax} + \frac{1}{2}Q_i}{\epsilon_s} \right| = \frac{C_{ox}V_T + \frac{1}{2}C_{ox}(V_{GS} - V_T)}{\epsilon_s} = \frac{\epsilon_{ox} V_{GS} + V_T}{\epsilon_s 2x_{ox}}$$

$$|\mathcal{E}_{av}| \simeq \frac{\epsilon_{ox}}{\epsilon_s} \frac{V_{GS} + V_T}{2x_{ox}}$$

Key dependences:

- $V_{GS} \uparrow \Rightarrow |\mathcal{E}_{av}| \uparrow \Rightarrow \mu_{eff} \downarrow$
- $V_T \uparrow \Rightarrow |\mathcal{E}_{av}| \uparrow \Rightarrow \mu_{eff} \downarrow$
- $x_{ox} \downarrow \Rightarrow |\mathcal{E}_{av}| \uparrow \Rightarrow \mu_{eff} \downarrow$

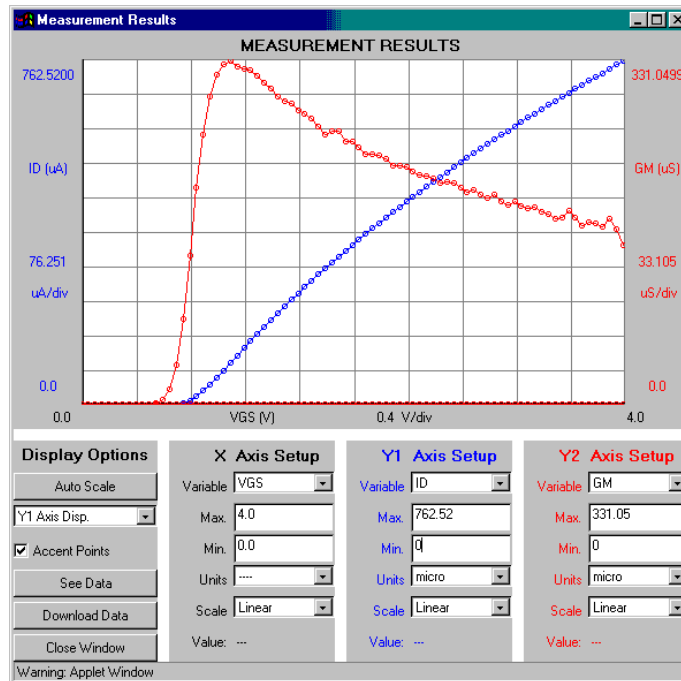
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Figure 5 in Ko, P. "Approaches to Scaling." *VLSI Electronics: Microstructure Science*. Edited by Norman G. Einspruch and Gennady Gildenblat. Vol. 18. Burlington, MA: Academic Press, 1989, chapter 1, pp. 1-37. ISBN: 9780122341182.

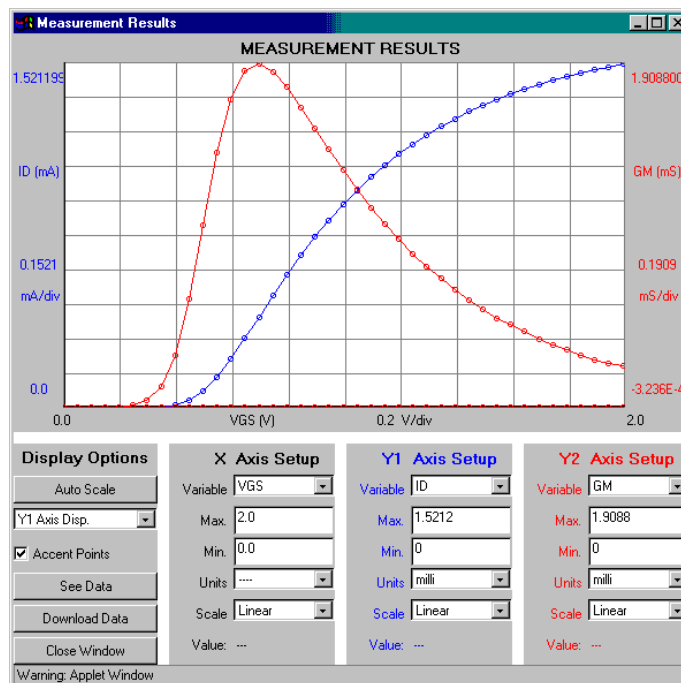
Several comments:

- Since $I_D \sim \mu_e$, mobility degradation more severe as V_{GS} increases $\Rightarrow I_D$ won't rise as fast with V_{GS} .
- Since μ_e depends on $|\mathcal{E}_{av}| \Rightarrow \mu_{eff}$ depends on y . Disregard to first order \Rightarrow use same μ_{eff} everywhere.
- Mobility degradation considered "short-channel effect" because as $L \downarrow \Rightarrow x_{ox} \downarrow$ and μ degradation becomes important.

g_m in linear regime ($V_{DS} = 0.1\text{ V}$) for $L_g = 1.5\ \mu\text{m}$ MOSFET:

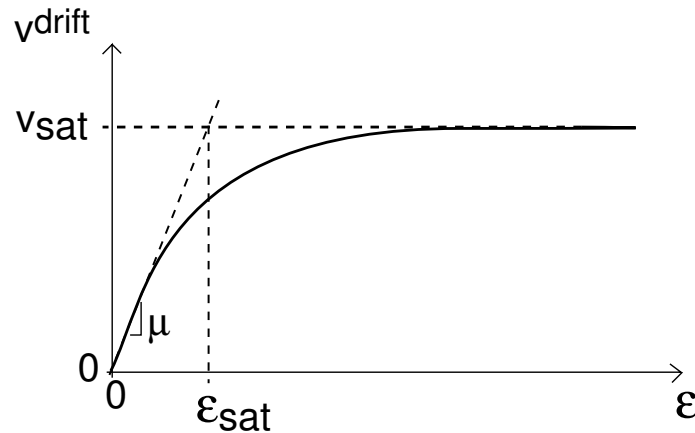


g_m in linear regime ($V_{DS} = 0.1\text{ V}$) for $L_g = 0.18\ \mu\text{m}$ MOSFET:



□ Velocity saturation

At high longitudinal fields, v_e cannot exceed v_{sat} :



Best fit to experiments:

$$v_e = \frac{\mu_e \mathcal{E}}{\left(1 + \left|\frac{\mu_e \mathcal{E}}{v_{sat}}\right|^n\right)^{1/n}}$$

For inversion layer:

	electrons	holes
v_{sat} (cm/s)	8×10^6 cm/s	6×10^6 cm/s
n	2	1

To develop analytical model, use $n = 1$:

$$v_e = \frac{\mu_e \mathcal{E}}{1 + \left|\frac{\mu_e \mathcal{E}}{v_{sat}}\right|}$$

New current model:

$$I_e = W \mu_e Q_i \frac{dV}{dy} = W \frac{\mu_e}{1 + \left| \frac{\mathcal{E}}{\mathcal{E}_{sat}} \right|} Q_i \frac{dV}{dy}$$

with

$$\mathcal{E}_{sat} = \frac{v_{sat}}{\mu_e}$$

Rewrite current equation:

$$I_e = \left[W \mu_e Q_i - \frac{I_e}{\mathcal{E}_{sat}} \right] \frac{dV}{dy}$$

Plug in fundamental charge relationship:

$$Q_i = -C_{ox}(V_{GS} - V - V_T)$$

and integrate along channel:

$$I_e L = -W \mu_e C_{ox} \int_0^{V_{DS}} (V_{GS} - V - V_T) dV - \frac{I_e}{\mathcal{E}_{sat}} V_{DS}$$

Solve for I_e :

$$I_e = -\frac{W \mu_e C_{ox}}{L + \frac{V_{DS}}{\mathcal{E}_{sat}}} (V_{GS} - V_T - \frac{1}{2} V_{DS}) V_{DS}$$

Terminal drain current in linear regime:

$$I_D = \frac{W}{L} \frac{\mu_e C_{ox}}{1 + \frac{V_{DS}}{\mathcal{E}_{sat} L}} (V_{GS} - V_T - \frac{1}{2} V_{DS}) V_{DS}$$

Effectively, impact of velocity saturation:

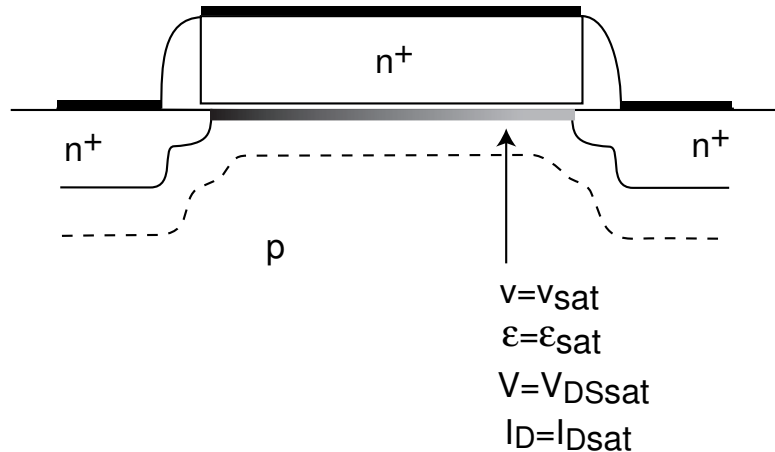
$$\mu_e \Rightarrow \frac{\mu_e}{1 + \frac{V_{DS}}{\mathcal{E}_{sat} L}}$$

with $\frac{V_{DS}}{L} \equiv$ *average longitudinal field*.

- For $\frac{V_{DS}}{L} \ll \mathcal{E}_{sat} \Rightarrow$ velocity saturation irrelevant (*mobility regime*).
- For $\frac{V_{DS}}{L} \gg \mathcal{E}_{sat} \Rightarrow$ velocity saturation prominent (*velocity saturation regime*).

Since $\mathcal{E}_{sat} \simeq 10^5$ V/cm and V_{DS} order 1 – 10 V, velocity saturation important if $L \sim 0.1 - 1$ μm .

Current saturation occurs when v_{sat} reached anywhere in the channel
 $\Rightarrow I_D$ won't increase anymore with V_{DS} :



Bottleneck is current flowing through v_{sat} region:

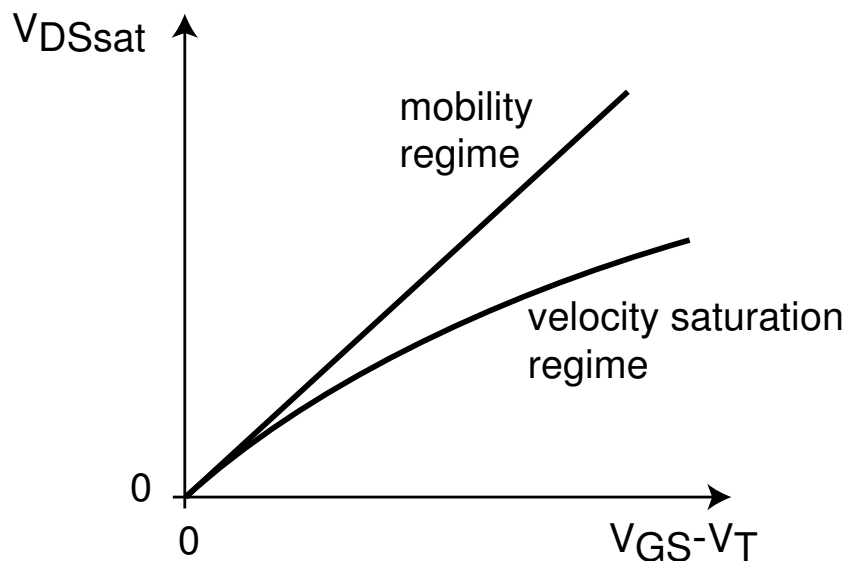
$$\begin{aligned}
 I_{Dsat} &= -W v_e Q_i \\
 &= W v_{sat} C_{ox} (V_{GS} - V_T - V_{DSsat}) \\
 &= \frac{W}{L} \frac{\mu_e C_{ox}}{1 + \frac{V_{DSsat}}{\epsilon_{sat} L}} (V_{GS} - V_T - \frac{1}{2} V_{DSsat}) V_{DSsat}
 \end{aligned}$$

Solve for V_{DSsat} :

$$V_{DSsat} = \epsilon_{sat} L \left(\sqrt{1 + 2 \frac{V_{GS} - V_T}{\epsilon_{sat} L}} - 1 \right)$$

$$V_{DSsat} = \mathcal{E}_{sat}L \left(\sqrt{1 + 2 \frac{V_{GS} - V_T}{\mathcal{E}_{sat}L}} - 1 \right)$$

- For long L , $V_{DSsat} \simeq V_{GS} - V_T$
- For short L , $V_{DSsat} \simeq \sqrt{2\mathcal{E}_{sat}L(V_{GS} - V_T)} < V_{GS} - V_T$



Velocity saturation results in *premature current saturation* and less current:

$$I_{Dsat} = W v_{sat} C_{ox} (V_{GS} - V_T - V_{DSsat})$$

Experiments:

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Figure 7 in Ko, P. "Approaches to Scaling." *VLSI Electronics: Microstructure Science*. Edited by Norman G. Einspruch and Gennady Gildenblat. Vol. 18. Burlington, MA: Academic Press, 1989, chapter 1, pp. 1-37. ISBN: 9780122341182.

Current-voltage characteristics:

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Figure 15 in Ko, P. "Approaches to Scaling." *VLSI Electronics: Microstructure Science*. Edited by Norman G. Einspruch and Gennady Gildenblat. Vol. 18. Burlington, MA: Academic Press, 1989, chapter 1, pp. 1-37. ISBN: 9780122341182.

Impact of velocity saturation on transconductance:

$$g_m = \frac{\partial I_{Dsat}}{\partial V_{GS}} = W v_{sat} C_{ox} \left(1 - \frac{\partial V_{DSsat}}{\partial V_{GS}} \right)$$

with

$$\frac{\partial V_{DSsat}}{\partial V_{GS}} = \frac{1}{\sqrt{1 + 2 \frac{V_{GS} - V_T}{\mathcal{E}_{sat} L}}}$$

Then:

$$g_m = W v_{sat} C_{ox} \left(1 - \frac{1}{\sqrt{1 + 2 \frac{V_{GS} - V_T}{\mathcal{E}_{sat} L}}} \right)$$

In the limit of short L :

$$g_m = W v_{sat} C_{ox}$$

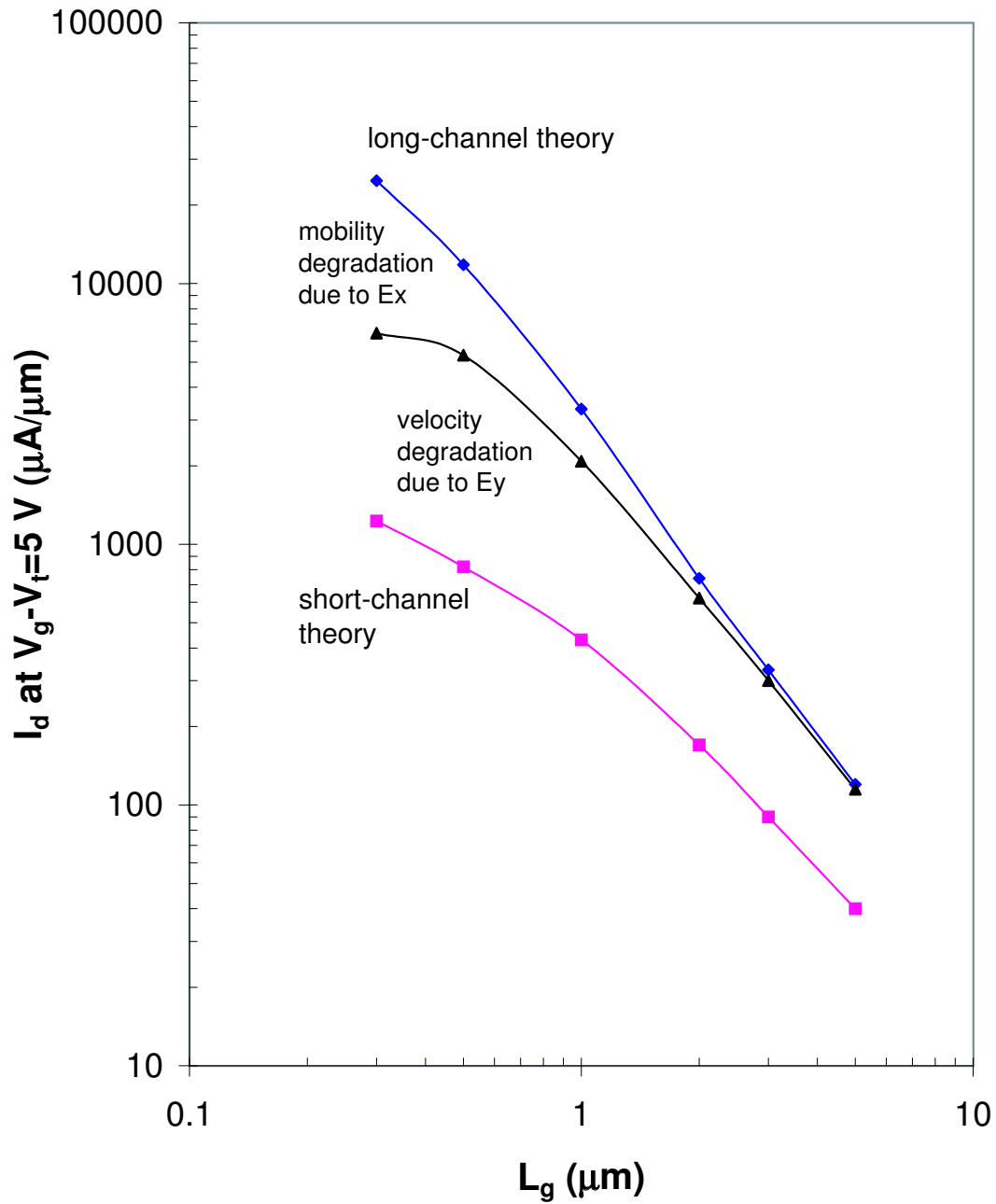
In the limit of short L , g_m determined only by x_{ox} .

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Figure 10 in Ko, P. "Approaches to Scaling." *VLSI Electronics: Microstructure Science*. Edited by Norman G. Einspruch and Gennady Gildenblat. Vol. 18. Burlington, MA: Academic Press, 1989, chapter 1, pp. 1-37. ISBN: 9780122341182.

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Figure 9 in Ko, P. "Approaches to Scaling." *VLSI Electronics: Microstructure Science*. Edited by Norman G. Einspruch and Gennady Gildenblat. Vol. 18. Burlington, MA: Academic Press, 1989, chapter 1, pp. 1-37. ISBN: 9780122341182.

MOSFET I_d scaling (Ko, 1989)

Key conclusions

- Inversion layer mobility degraded by transversal field due to roughness of semiconductor-oxide interface $\Rightarrow I_D$ lower than predicted by simple models.
- There is a *universal relationship between mobility and average transversal field in inversion layer*.
- For short L , velocity saturation in inversion layer important $\Rightarrow I_D$ lower than predicted by simple models.
- Velocity saturation \Rightarrow premature MOSFET saturation $\Rightarrow V_{DSsat}$ lower than predicted by simple models.
- Velocity saturation $\Rightarrow g_m$ saturation in limit of short L :

$$g_m = W v_{sat} C_{ox}$$